

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/602,089
Priority Filing Date June 22, 2000
Inventor Kevin L. Beaman et al.
Assignee Micron Technology, Inc.
Priority Group Art Unit 2818
Priority Examiner David Nhu
Attorney's Docket No. MI22-2475
Title: Semiconductor Assemblies, Methods of Forming Structures over
Semiconductor Substrates, and Methods of Forming Transistors Associated
with Semiconductor Substrates

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
Commissioner for Patents
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Sir:

This is a preliminary amendment accompanying a Request for Continuation Application for the above-entitled patent application. Prior to examining the application, please enter the following amendments.

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.